



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **IBARA, Yoshikazu et al.**

Group Art Unit: 2823

Serial No.: 09/892,893

Examiner: **COLEMAN, William D.**

Filed: **June 28, 2001**

**P.T.O. Confirmation No.: 1585**

For. **METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICES WITH  
SILICIDE FILMS THEREON**

**PRELIMINARY AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Date: July 25, 2003

Sir:

Please amend the above-captioned patent application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of  
this paper.

**Remarks** begin on page 4 of this paper.

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